

## **REMARKS**

Claims 1-45 have been canceled and new claims 46-60 have been added.

New claims 46-60 are supported at least by p. 4, line 5 through p. 13, line 3 of the application as originally filed. No new matter is added by new claims 46-60.

Attached hereto is a marked-up version of the changes made to the specification and claims by the current amendment. The attached page(s) are captioned "**Version with markings to show changes made.**"

This application is believed to be in condition for allowance and action to that end is requested. The Examiner is requested to telephone the undersigned in the event that the next office action is one other than a Notice of Allowance. The undersigned is available during normal business hours (Pacific Time Zone).

Respectfully submitted,

Dated: June 6, 2001

By: 

Frederick M. Fliegel, Ph.D.  
Reg. No. 36,138



Version with markings to show changes made.

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

Priority Application Serial No. .... 08/886,388  
Priority Filing Date ..... July 1, 1997  
Inventor ..... Gurtej S. Sandhu et al.  
Assignee ..... Micron Technology, Inc.  
Priority Group Art Unit ..... 2811  
Priority Examiner ..... Sara W. Crane  
Attorney's Docket No. .... MI22-1736  
Title: Method of Forming a Capacitor and a Capacitor Construction

**37 CFR §1.121(b)(1)(iii) AND 37 CFR §1.121(c)(1)(ii)**  
**FILING REQUIREMENTS TO ACCOMPANY PRELIMINARY AMENDMENT**

Deletions are bracketed, additions are underlined.

**In the Specification**

At page 1, after the title, the following was inserted:

**CROSS REFERENCE TO RELATED APPLICATION**

This patent application is a Continuation of U.S. Patent Application  
Serial No. 08/886,388 filed July 16, 1997, entitled "Method of Forming a  
Capacitor and a Capacitor Construction", naming Gurtej S. Sandhu and Pierre  
C. Fazan as inventors, which is a divisional application of United States  
Patent Application Serial No. 08/582,385, which was filed January 3, 1996,  
now U.S. Patent No. 6,218,237.

RECEIVED  
JUN 20 2003  
TECHNOLOGY CENTER

**END OF DOCUMENT**